(19) Europäisches Patentamt
European Patent Office
Office européen des brevets

(11) Publication number: **0 000 449**
**B1**

(12) # EUROPEAN PATENT SPECIFICATION

(45) Date of publication of patent specification: **21.10.81**

(51) Int. Cl.³: **H 01 L 41/22**

(21) Application number: **78300160.5**

(22) Date of filing: **18.07.78**

(54) **Improvements in or relating to piezoelectric materials and to methods for producing such materials.**

(30) Priority: **19.07.77 GB 3023777**

(43) Date of publication of application:
**24.01.79 Bulletin 79/2**

(45) Publication of the grant of the European patent:
**21.10.81 Bulletin 81/42**

(84) Designated Contracting States:
**BE DE FR GB NL SE**

(56) References cited:
**FR - A - 2 031 247**
**FR - A - 2 108 561**

**CHEMICAL ABSTRACTS, Vol. 83, No. 6**
**11 August 1975**
**Columbus Ohio USA**
**HASEGAWA YO et al. "Vacuum treatment of electrets to stabilize their surface change", page 590, 1st column, abstract no. 52 017 U.**

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**EP 0 000 449 B1**

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Courier Press, Leamington Spa, England.

# Improvements in or relating to piezoelectric materials and to methods for producing such materials

This invention relates to piezoelectric materials and to methods for producing such materials. The invention has particular reference to polymeric materials exhibiting piezoelectric properties and to the production of such materials for use in electro-acoustic transducer devices.

It has been found that certain polymeric materials, for example polyvinylidene fluoride (hereinafter referred to as $PVF_2$), exhibit piezoelectric properties, and that these properties can be enhanced considerably by exposing the material to treatment known as "poling" or "polarising". Poling or polarising involves the application to the material of a high electric field, usually at an elevated temperature.

In practice, the material, usually in the form of a film, has electrodes applied to both faces, is placed in an oven and when at the required temperature a polarising voltage is applied across the electrodes. Typically, temperatures in the range of from 100°C—120°C are used in conjunction with voltages in the order of one megavolt per centimetre of film thickness. An example of such a treatment is given in French patent application No. 2 108 561 of Kureha Kagaku Kogyo Kabushiki Kaisha.

The enhanced level of piezoelectricity produced in the film is a function of the magnitude of both the treatment temperature and the applied electric field. However, the extent to which the treatment temperature can be raised is limited by the melting point of the material, whilst the extent to which the applied electric field can be increased is limited by the dielectric strength of the film. Defects in the film for example bubbles, pin holes, scratches and included foreign bodies constitute weak spots in the film and electrical breakdown of the film is liable to occur at such spots. When breakdown occurs, damage is caused to the film and to the electrodes and results sometimes in the rejection of a length of film which is thus wasted. Breakdowns are more frequent at higher applied electric fields and elevated temperatures.

Thus, although it is known that greater enhancement of piezoelectric activity is obtainable by using higher applied electric fields and elevated temperatures, it has not been possible to take full advantage of this for the reasons set out above.

French patent application No. 2 031 247 of Western Electric Company Incorporated refers to the possibility of obtaining an electret by electron bombardment of a dielectric.

According to the present invention a method of enhancing the piezoelectric properties of a polymeric material exhibiting such properties is characterised in that, before subjecting the material to a "poling" treatment in an electric field, the material is exposed whilst in an atmosphere inert with respect to the material and at substantially room temperature to a dose of gamma ($\gamma$) radiation lying within the range of from about 1 Mrad to about 99 Mrads.

Specifically, the invention also provides a method of enhancing the piezoelectric activity of polyvinylidene fluoride by exposing the latter whilst in an atmosphere inert with respect thereto and at substantially room temperature to a dose of $\gamma$ radiation lying within the range of from about 1 Mrad to about 99 Mrads after which the material is subjected to a poling treatment.

The improved enhancement of the piezoelectric properties of the material renders the material more useful in nearly all of its applications. For example, it improves the sensitivity of an electro-acoustic transducer fitted with a piezoelectric material according to the invention.

In one method embodying the invention the polyvinylidene fluoride is in the physical form of a biaxially oriented film.

The phrase "in an atmosphere inert with respect to the material", or "in an atmosphere inert with respect thereto" is intended to include irradiation in a vacuum in which the air pressure does not exceed $10^{-3}$ mm Hg (0.13 $N/m^2$) as well as irradiation in an atmosphere that does not cause embrittlement of the material undergoing irradiation. It has been found that it is important to exclude oxygen from the atmosphere. An example of an inert atmosphere is a nitrogen atmosphere and this can be obtained by flushing out with nitrogen the chamber in which irradiation is to be effected to remove all air.

The dose of $\gamma$ radiation to which the material is exposed preferably lies in the range of from 12 Mrad to 99 Mrads (both limits included). The enhancement of the piezoelectric properties of the material is known to be particularly pronounced at these exposure levels.

The invention also provides a polymeric material exhibiting piezoelectric properties which have been enhanced by a method as defined above.

By way of example only, a method of enhancing the piezoelectric activity of biaxially orientated polyvinylidene fluoride film will now be described with reference to Figure 1, the accompanying drawing, which is a schematic sectional view of a sample of the film being irradiated.

Prior to irradiation, vacuum evaporated aluminium electrodes are formed on both sides of the film using conventional techniques. Referring to Figure 1, a strip of the film 1 having, for example, a thickness of 25 $\mu$m, a width of about 30 cm and a length of a few hundred metres, is then wound onto a reel 2 and placed

in a dessicator 3, maintained at room temperature and exhausted to $10^{-5}$ mm Hg ($1.3 \times 10^{-3}$ N/m$^2$), oxygen being excluded. The dessicator is in turn placed in a concrete bunker 5 and irradiated from a source of radiation 6, for example Cobalt 60. The film 1 is exposed to a preselected dose of radiation lying within the range of from 1 to 99 Mrads and illustrated schematically by arrows 4 in Figure 1; the direction and intensity of radiation incident on the film depends on the position of the dessicator 3 in the bunker. After irradiation, the dessicator 3 is removed from the bunker, the reel 2 is removed from the dessicator and the film is poled by application across the electrodes of an electric field while the film is at an elevated temperature.

In the method described above, the aluminium electrodes are formed on the film before irradiation but the formation of electrodes may be deferred until after irradiation if desired.

Samples of films treated in various ways have been tested. In the tests the film was that produced by the firm Kureha Kagaku Kogyo Kabushiki Kaisha of Tokyo, Japan and is of 25 $\mu$m thickness. Prior to treatment vacuum evaporated aluminium electrodes were formed on both sides of the film using conventional techniques.

The sample was then placed in a vacuum chamber maintained at room temperature and exhausted to $10^{-5}$ mm Hg ($1.3 \times 10^{-3}$ N/m$^2$), oxygen being excluded. The chamber was then removed to a source of $\gamma$ radiation, namely Cobalt 60. After irradiation, the sample was removed. Subsequently, the sample was "poled" by application across the electrodes of an electric field while the sample was at an elevated temperature.

After poling the sample was subjected to tests to measure its piezoelectric activity. The activity was measured by stressing the sample in a direction lying along the machine or roll direction of the film.

The following table shows the piezoelectric activity of the film. The first column of the table sets out the irradiation treatment to which the portion of film was exposed, whilst the second column gives details of the "poling" treatment. Of the details given in the second column, the first figure is the poling field, the second is the poling temperature and the third is the duration of the poling treatment. The third column gives the measured value of the piezoelectric coefficient for stress applied along the machine direction.

| Irradiation Treatment | Poling Treatment | Piezoelectric voltage coefficient $g_{31}$ (Vm/N) |
|---|---|---|
| None | None | $1.8 \times 10^{-5}$ |
| None | 0.5 MV/cm, 100°C, 45 min. | $1.4 \times 10^{-2}$ |
| 200 Mrad | 0.25 MV/cm, 100°C, 45 min. | $1.2 \times 10^{-2}$ |
| 53 Mrad | 0.5 MV/cm, 100°C, 45 min. | $3.4 \times 10^{-2}$ |
| 99 Mrad | 0.5 MV/cm, 100°C, 45 min. | $2.9 \times 10^{-2}$ |
| None | 1.0 MV/cm, 100°C, 45 min. | $3.8 \times 10^{-2}$ |
| 12 Mrad | 1.0 MV/cm 100°C, 45 min. | $5.8 \times 10^{-2}$ |
| 25 Mrad | 1.0 MV/cm 100°C, 45 min. | $6.1 \times 10^{-2}$ |
| 53 Mrad | 1.0 MV/cm, 100°C, 45 min. | $6.1 \times 10^{-2}$ |
| 99 Mrad | 1.0 MV/cm, 100°C, 45 min. | $3.6 \times 10^{-2}$ |

It will be observed that there is a substantial increase in piezoelectric activity in certain of the samples as a result of the pre-poling irradiating treatment.

It will be appreciated that a given level of piezoelectric activity may be produced by employing the irradiation treatment in conjunction with a poling treatment employing lower levels of polarising potential than would be necessary to produce that level of piezoelectric activity employed without irradiation. Such a combination will enable material which would previously have been rejected as defective to be utilised.

Polymeric materials, other than polyvinylidene fluoride, which exhibit latent piezoelectricity may also be treated by processes embodying the invention. While not constituting a limitation in the scope of the invention, such other materials would importantly include copolymers of polyvinylidene fluoride, e.g. coplymer of ethylene and vinylidene fluoride, copolymer of vinylidene fluoride and tetrafluoroethylene, copolymer of vinylidene fluoride and vinyl fluoride, copolymer of vinylidene fluoride and trifluoromonochloroethylene, and the like. Also included are such halogen containing polymers as polyvinyl fluoride, polyvinyl chloride and the like.

In addition, it is not essential that the material be in film form or in the form of a biaxially orientated film.

As piezoelectrical properties are intimately linked with pyro-electrical properties, it is likely that the above described treatment will also enhance the pyroelectric coefficient of the material.

The treated material is suitable for use in microphone transmitters, receivers and pressure transducers.

**Claims**

1. A method of enhancing the piezoelectric properties of a polymeric material (1) exhibiting such properties, the method including the step of subjecting the material to a "poling" treatment in an electric field, characterised in that, before the "poling" treatment, the material (1) is exposed whilst in an atmosphere inert with respect to the material and at substantially room temperature to a dose of $\gamma$ radiation (4) lying within the range of from about 1 Mrad to about 99 Mrads.

2. A method as claimed in claim 1, further characterised in that the material (1) is polyvinylidene fluoride.

3. A method as claimed in claim 2, further characterised in that the polyvinylidene fluoride is in the form of a biaxially oriented film.

4. A method as claimed in any preceding claim, further characterised in that the inert atmosphere is a vacuum in which the air pressure does not exceed $10^{-3}$ mm Hg (0.13 $N/m^2$).

5. A method as claimed in any preceding claim, further characterised in that the dose of $\gamma$ radiation (4) to which the material (1) is exposed lies in the range of from 12 Mrad to 99 Mrads (both limits included).

6. A polymeric material exhibiting piezoelectric properties characterised in that the piezoelectric properties of the material (4) have been enhanced by a method as claimed in any preceding claim.

**Revendications**

1. Procédé pour améliorer les propriétés piézo-électriques d'une matière polymère (1) manifestant de telles propriétés, suivant lequel on soumet la matière à un traitement de polarisation dans un champ électrique, caractérisé en ce qu'avant le traitement de polarisation, on expose la matière (1), tandis qu'elle se trouve dans une atmosphère inerte à l'égard de la matière et sensiblement à la température ambiante, à une dose de rayonnement gamma (4) tombant dans l'intervalle d'environ 1 mégarad à environ 99 mégarads.

2. Procédé suivant la revendication 1, caractérisé en outre en ce que la matière (1) est le poly(fluorure de vinylidène).

3. Procédé suivant la revendication 2, caractérisé en outre en ce que le poly(fluorure de vinylidène) est présenté sous forme de pellicule orientée biaxialement.

4. Procédé suivant l'une quelconque des revendications précédentes, caractérisé en outre en ce que l'atmosphère inerte est un vide dans lequel la pression de l'air n'excède pas $10^{-3}$ mm Hg (0,13 $N/m^2$).

5. Procédé suivant l'une quelconque des revendications précédentes, caractérisé en outre en ce que la dose de rayonnement gamma (4) à laquelle la matière (1) est exposée tombe dans l'intervalle de 12 mégarads à 99 mégarads (limites incluses).

6. Matière polymère manifestant des propriétés piézo-électriques, caractérisée en ce que les propriétés piézo-électriques de la matière (1) ont été améliorées par un procédé suivant l'une quelconque des revendications précédentes.

**Patentansprüche**

1. Ein Verfahren zum Steigern der piezoelektrischen Eigenschaften eines Polymermaterials (1), das solche Eigenschaften aufweist, welches Verfahren den Schritt einschließt, das Material einer "Polarisierungs-" Behandlung in einem elektrischen Feld zu unterwerfen, dadurch gekennzeichnet, daß das Material (1) vor der "Polarisierungs-" Behandlung in einer bezüglich des Materials inerten Atmosphäre und im wesentlichen bei Zimmertemperatur einer Gammabestrahlungsdosis (4) ausgesetzt wird, die innerhalb des Bereichs von etwa 1 Mrad bis etwa 99 Mrad liegt.

2. Ein Verfahren nach Anspruch 1, weiter dadurch gekennzeichnet, daß das Material (1) Polyvinylidenfluorid ist.

3. Ein Verfahren nach Anspruch 2, weiter dadurch gekennzeichnet, daß das Polyvinylidenfluorid in Form einer biaxial orientierten Folie vorliegt.

4. Ein Verfahren nach einem der vorangehenden Ansprüche, weiter dadurch gekennzeichnet, daß die inerte Atmosphäre ein Vakuum ist, in welchem der Luftdruck $10^{-3}$ mm Hg (0.13 $N/m^2$) nicht übersteigt.

5. Ein Verfahren nach einem der vorangehenden Ansprüche, weiter dadurch gekennzeichnet, daß die Gammabestrahlungsdosis (4), der das Material (1) ausgesetzt wird, im Bereich von 12 Mrad bis 99 Mrad (beide Grenzwerte eingeschlossen) liegt.

6. Ein piezoelektrische Eigenschaften aufweisendes Polymermaterial, dadurch gekennzeichnet, daß die piezoelektrischen Eigenschaften des materials (4) durch ein Verfahren nach einem der vorangehenden Ansprüche gesteigert worden sind.

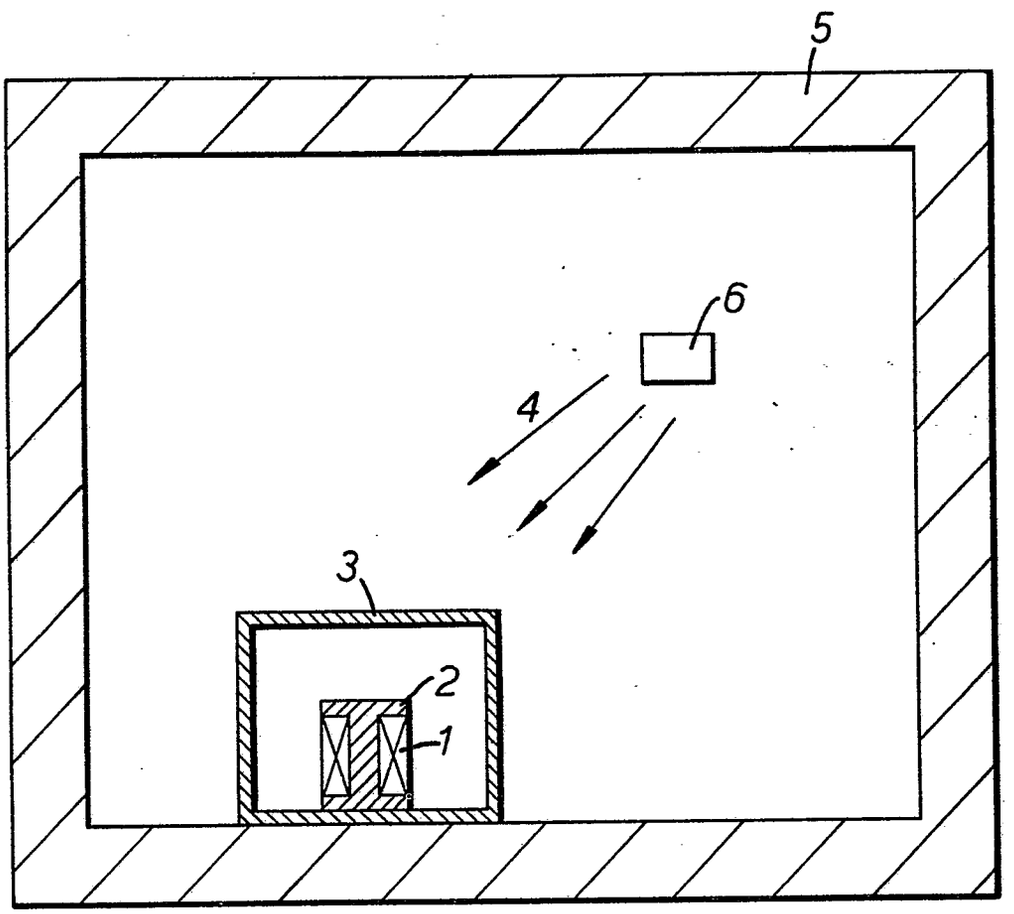



FIG.1.